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OCT 17 2003
PATENT & TRADEMARK OFFICE
JC34
Docket No.: 50090-306

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AF 12823

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
BEFORE THE BOARD OF PATENT APPEALS AND INTERFERENCES

In re Application of
Hiroshi TOBIMATSU, et al.
Serial No.: 09/910,824
Filed: July 24, 2001

: Customer Number: 20277
: Confirmation Number: 3928
: Group Art Unit: 2823
: Examiner: LEE, Hsien Ming

For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE HAVING
PASSIVATION FILM AND BUFFER COATING FILM

NOTICE OF APPEAL
FROM THE PRIMARY EXAMINER
TO THE BOARD OF APPEALS

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant(s) hereby appeal(s) to the Board of Appeals from the decision dated June 18, 2003
of the Primary Examiner finally rejecting claims 1 through 4 and 6.

Appeal Fee: \$330.00

- Not required (fee paid in prior appeal in this application).
- Charge to Deposit Account No. 500417.
- Check Enclosed.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

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for /

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